



IFW

Docket No.: 57810-086

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Yoshikazu IBARA	:	Confirmation Number: 6031
Serial No.: 10/768,170	:	Group Art Unit: 2825
Filed: February 02, 2004	:	Examiner: Caridad Everhart
For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE	:	

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and remarks are submitted in response to the Office Action June 25, 2004.